


**INFORMATION DISCLOSURE
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ATTY. DOCKET NO.

SERIAL NO.

4110-2

10/026,951

APPLICANT

KEREN et al.

(Use several sheets if necessary)

FILING DATE

GROUP

December 27, 2001

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JS	5,872,625	2/1999	KAJINO et al.	—	—	
JS	4,810,895	3/1989	KAFRI et al.	—	—	
JS	4,459,027	7/1984	KAFRI et al.	—	—	

FOREIGN PATENT DOCUMENTS

DOCUMENT	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO

OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

JS	Oster et al., "Moiré Patterns", <u>Scientific American</u> , 208, pp. 54-63, 1963.
JS	Nishijima et al., "Moiré Patterns: Their Application to Refractive Index and Refractive Index Gradient Measurements", <u>Journal of the Optical Society of America</u> , Vol. 54, pp. 1-5, January 1964
JS	Benton et al., "Simplified Talbot Interferometers for Lens Testing", <u>Optical Engineering</u> , Vol. 15, pp. 328-331, July-August 1976.
JS	Bolognini et al., "Interferometry based on the Lau effect a quasi-ray description", <u>Optica Acta</u> , Vol. 32, pp. 409-422, 1985.
JS	Pirga-et-al., "Two directional spatial-carrier phase-shifting method for analysis of crossed and closed fringe patterns", <u>Optical Engineering</u> , pp. 2459-2466, Vol. 34, August 1995.
JS	Morimoto et al., "Application of moire analysis of strain using Fourier transform", <u>Optical Engineering</u> , pp. 650-656, Vol. 27, August 1988.
JS	Keren et al., "An Optical Method for Mapping the Power and Cylinder of Multifocal Progressive Lenses", <u>Ophthalmic & Visual Optics/Noninvasive Assessment of the Visual System Technical Digest</u> , Vol. 3, PD1-1 through PD1-4, 1983.

*Examiner Mickael Stefan Date Considered 3-2-04

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.

Form PTO-FB-A820 (Also PTO-1449)

